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AN/"Semprius Inc"

PAT. NO.	Title
1 <a href="#">9,660,008</a>	<a href="#">High-yield fabrication of large-format substrates with distributed, independent control elements</a>
2 <a href="#">9,603,259</a>	<a href="#">Methods for surface attachment of flipped active components</a>
3 <a href="#">9,601,671</a>	<a href="#">Optical systems fabricated by printing-based assembly</a>
4 <a href="#">9,496,155</a>	<a href="#">Methods of selectively transferring active components</a>
5 <a href="#">9,443,883</a>	<a href="#">Methods of forming printable integrated circuit devices and devices formed thereby</a>
6 <a href="#">9,412,727</a>	<a href="#">Printing transferable components using microstructured elastomeric surfaces with pressure modulated reversible adhesion</a>
7 <a href="#">9,401,344</a>	<a href="#">Substrates with transferable chiplets</a>
8 <a href="#">9,362,113</a>	<a href="#">Engineered substrates for semiconductor epitaxy and methods of fabricating the same</a>
9 <a href="#">9,355,854</a>	<a href="#">Methods of fabricating printable compound semiconductor devices on release layers</a>
10 <a href="#">9,343,363</a>	<a href="#">Through-silicon vias and interposers formed by metal-catalyzed wet etching</a>
11 <a href="#">9,307,652</a>	<a href="#">Methods for surface attachment of flipped active components</a>
12 <a href="#">9,165,989</a>	<a href="#">High-yield fabrication of large-format substrates with distributed, independent control elements</a>
13 <a href="#">9,161,448</a>	<a href="#">Laser assisted transfer welding process</a>
14 <a href="#">9,142,468</a>	<a href="#">Structures and methods for testing printable integrated circuits</a>
15 <a href="#">9,117,940</a>	<a href="#">Optical systems fabricated by printing-based assembly</a>
16 <a href="#">9,049,797</a>	<a href="#">Electrically bonded arrays of transfer printed active components</a>
17 <a href="#">9,040,425</a>	<a href="#">Methods of forming printable integrated circuit devices and devices formed thereby</a>
18 <a href="#">8,934,259</a>	<a href="#">Substrates with transferable chiplets</a>
19 <a href="#">8,894,754</a>	<a href="#">Breathing and desiccant regenerating cycle for reducing condensation in concentrator photovoltaic modules</a>
20 <a href="#">8,889,485</a>	<a href="#">Methods for surface attachment of flipped active componenets</a>
21 <a href="#">8,877,648</a>	<a href="#">Methods of forming printable integrated circuit devices by selective etching to suspend the devices from a handling substrate and devices formed thereby</a>
22 <a href="#">8,722,458</a>	<a href="#">Optical systems fabricated by printing-based assembly</a>
23 <a href="#">8,506,867</a>	<a href="#">Printing semiconductor elements by shear-assisted elastomeric stamp transfer</a>
24 <a href="#">8,470,701</a>	<a href="#">Printable, flexible and stretchable diamond for thermal management</a>

25 [8,261,660](#)  [Vacuum coupled tool apparatus for dry transfer printing semiconductor elements](#)

26 [7,999,454](#)  [OLED device with embedded chip driving](#)

27 [7,927,976](#)  [Reinforced composite stamp for dry transfer printing of semiconductor elements](#)

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